



Docket No.: 50099-180

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Shigenobu MAEDA, et al. :
Application No.: 09/988,593 : Group Art Unit: 2823
Filed: November 20, 2001 : Examiner: T. Pham
For: SEMICONDUCTOR DEVICE HAVING IMPURITY REGION UNDER ISOLATION
REGION (As amended)

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3/14/3
Susler

AMENDMENT

Box Non-Fee Amendment
The Commissioner for Patents and Trademarks
Washington, DC 20231

Sir:

The following Amendment and Remarks are submitted in response to the Office Action
dated December 13, 2002. Please amend the above-identified application as follows:

IN THE TITLE:

Please replace "SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING
THE SAME" with --SEMICONDUCTOR DEVICE HAVING IMPURITY REGION UNDER
ISOLATION REGION--.

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IN THE SPECIFICATION:

Please delete the first two full paragraphs in page 21 in their entirety and replace with the
following: